IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

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SONG, You-Lee; and JUN, Sahng-Ik

Assignee:

Samsung Electronics Co., Ltd.

Title:

THIN FILM TRANSISTOR ARRAY PANEL, MANUFACTURING

METHOD THEREOF, AND MASK THERFOR

Application No.:

10/771,278

Filing Date:

February 2, 2004

Examiner:

ROSASCO, Stephen D. Group Art Unit:

1756

Docket No.:

AB-1353 US

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2069

San Jose, California October 10, 2006

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Dear Sir:

In response to the Restriction Requirement having a mailing date of September 7, 2006, Applicants hereby elect for further prosecution in this application the invention of Group I (Claims 1-5, drawn to a Thin Film Transistor array panel, classified in class 257, subclass 292).

Applicants withdraw the non-elected claims of Group II (Claims 6-9, drawn to a mask, classified in class 430, subclass 5) and Group III (Claims 10-23, drawn to a method of making a TFT array panel, classified in class 430, subclass 311), reserving the right to prosecute those claims in other applications.

The Examiner is invited to call the undersigned at (408) 392-9250 with any questions regarding the above-identified application.

EXPRESS MAIL LABEL NO.

EV 901 346 189 US

Respectfully submitted,

David W. Heid

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